

JC20 Rec'd PCT/PTO 13 MAY 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:	Haruki NOJO et al.	Confirmation No:
Serial No.:	To be assigned (National Stage of PCT/US03/36618)	Art Unit: To be assigned
Filed:	May 12, 2005	Examiner: To be assigned
For:	<b>CHEMICAL MECHANICAL POLISHING COMPOSITION AND PROCESS</b>	Attorney Docket No: 063254-0233-US

## PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office  
Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, Virginia 22314

Sir:

Prior to examination of the above-referenced application on the merits, the Examiner is respectfully requested to consider the following amendments and comments:

**Amendments to the claims** begin at page 2; and

**Remarks** begin at page 8.